		ISSUE CLASSIFICATION			
438	692				
Class	Subclass				

UTILITY SERIAL NUMBER	PATENT DATE	PATENT NUMBER

SERIAL NUMBER 08/921,250	FILING DATE 08/29/97	CLASS 438	SUBCLASS 692	GROUP ART UNIT 1763	EXAMINER Goudreau

APPLICANTS

YASUNORI INOUE, GIFU, JAPAN; YOSHIO OKAYAMA, GIFU, JAPAN.

CONTINUING DATA**************
VERIFIED

gng 4-98

FOREIGN/PCT APPLICATIONS**********
VERIFIED   JAPAN   8-230826 (P)   08/30/96
gng 4-98 JAPAN   9-010426 (P)   01/23/97

Foreign priority claimed ☒ yes ☐ no 35 USC 119 conditions met ☒ yes ☐ no Verified and Acknowledged _____ Examiner's Initials	AS FILED →	STATE OR COUNTRY JPX	SHEETS DRWGS. 14	TOTAL CLAIMS 24 30	INDEP. CLAIMS 1	FILING FEE RECEIVED $1,150.00	ATTORNEY'S DOCKET NO. 970813

ADDRESS

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TITLE

FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE LIQUID USED THEREIN

U.S. DEPT. OF COMM./ PAT. & TM—PTO-436L (Rev.12-94)

PARTS OF APPLICATION FILED SEPARATELY		Applications Examiner

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
6-3-03	Assistant Examiner	Total Claims 24	Print Claim 1

ISSUE FEE			DRAWING		
Amount Due $1300.00	Date Paid	GEORGE GOUDREAU PRIMARY EXAMINER 6-03 Primary Examiner	Sheets Drwg. 14	Figs. Drwg. 32	Print Fig. 7

	ISSUE BATCH NUMBER
Label Area	PREPARED FOR ISSUE

Form PTO-436A (Rev. 8/92)

(FACE)